

<b>Notice of References Cited</b>	Application/Control No. 10/748,277		Applicant(s)/Patent Under Reexamination KIM ET AL.	
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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2003/0106645	06-2003	Ni et al.	156/345.48
*	C	US-2002/0140359	10-2002	Chen et al.	315/111.21
	D	US-			
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	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	N	WO-0000993	01-2000	PCT	Chen et al.	—
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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